

MS AF

**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2811**

PATENT
0649-0901P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Takeshi MISAWA	Conf.:	9184
Appl. No.:	10/620,461	Group:	2811
Filed:	July 17, 2003	Examiner:	Thomas J. MAGEE
For:	SEMICONDUCTOR DEVICE AND METHOD FOR AMNUFACTURING SAME		

LARGE ENTITY TRANSMITTAL FORM
FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 12, 2004

Sir:

Transmitted herewith is an Amendment After Final in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT					HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	16	-	20	=	0			\$ 18	\$0.00
INDEPENDENT	3	-	3	=	0			\$ 88	\$0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM								\$300	\$0.00
								TOTAL	\$0.00

- ☐ Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ Check(s) in the amount of \$0.00 is(are) enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

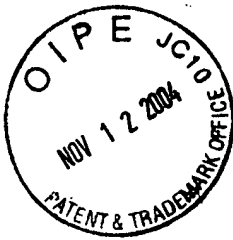
BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 
Michael R. Cammarata, #39,491

MRC/CJB:cb
0649-0901P

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment(s)



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REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 9184

PATENT
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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Takeshi MISAWA	Conf.:	9184
Appl. No.:	10/620,461	Group:	2811
Filed:	July 17, 2003	Examiner:	Thomas J. MAGEE
For:	SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME		

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 12, 2004

Sir:

In reply to the Office Action dated August 12, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Remarks.